

MAIL STOP PCT

Docket No. 270968US2X PCT

IN RE APPLICATION OF: Shinsuke HARADA, et al.

SERIAL NO: 10/531,582

FILED: April 18, 2005

FOR: SILICON CARBIDE SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Transmitted herewith is an amendment in the above-identified application.

- No additional fee is required
- Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- Additional documents filed herewith: Letter Submitting Replacement Drawing Sheets
Replacement Drawings (Pages 3, 13, and 14)

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	26	MINUS	28	0	x \$50 =	\$0.00
INDEPENDENT	4	MINUS	4	0	x \$200 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$360 =	\$0.00
						TOTAL OF ABOVE CALCULATIONS
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
						TOTAL
						\$0.00

- A check in the amount of \$0.00 is attached.
- Credit card payment form is attached to cover the fees in the amount of \$0.00
- Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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Docket No.: 270968US-2X PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION: Shinsuke HARADA, et al.

SERIAL NO.: 10/531,582

GAU:

FILED: April 18, 2005

EXAMINER:

FOR: SILICON CARBIDE SEMICONDUCTOR DEVICE AND ITS MANUFACTURING
METHOD

LETTER SUBMITTING REPLACEMENT DRAWING SHEET(S)

COMMISSIONER FOR PATENTS
Alexandria, VA 22313

SIR:

Prior to a first examination on the merits, the following drawing sheets are submitted herewith:

- 3 Replacement Drawing Sheets _____ New Drawing Sheets
- Official Action dated _____
 Notice of Allowance/Issue Fee dated _____
 Other dated _____

The changes and/or modifications made include the following:

Replacement Fig. 3(c) now properly labels element 7. Replacement Fig. 13(c) now includes all portions of element 7, including the portions at the edge of that figure. Replacement Fig. 14(b) now properly labels element 3.

Respectfully Submitted,

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